



Docket No.: 059516-0052

Corres. and Mail
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zi-kui LIU, et al.

RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE

Application No.: 10/784,899

Customer No.: 20277

Filed: February 24, 2004

Confirmation No.: 1022

Group Art Unit: 1762

Examiner: Brian K. Talbot

Title: BORIDE THIN FILMS ON SILICON

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Remarks and attached Declaration under 37 C.F.R. § 1.132 are submitted
in response to the Office Action dated September 2, 2005.